

U.S. DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

PATENT WITHDRAWAL NOTICE

DATE WITHDRAWN

4/25/2007

WITHDRAWAL NUMBER

15429

The following application has been **WITHDRAWN** from the

Tuesday, May 01, 2007 issue.

SERIAL NO.

10/827,449

PATENT NUMBER

7,212,710

DRAWINGS

0

CLASS

385/039.000

TITLE

BEAM HOMOGENIZER, LASER IRRADIATION APPARATUS, AND METHOD FOR
MANUFACTURING SEMICONDUCTOR DEVICE

NAME AND ADDRESS

TANAKA, KOICHIRO
Atsugi, Japan

REASON FOR WITHDRAWAL

The application is being withdrawn to allow reopening of prosecution.

APPROVED

/ Mary Louise McAskill, Manager /

Statistical Analysis Division